

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Divisional Patent Application of )  
Taiji NODA )  
Based On Application No. 09/981,806 ) Attn: Applications  
Filed: October 19, 2001 ) Branch  
For: SEMICONDUCTOR DEVICE AND )  
METHOD FOR MANUFACTURING )  
THE SAME ) Date: August 19, 2003

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98.

The references listed on the attached Form PTO-1449 were cited in parent application Serial No. 09/981,806 filed October 19, 2001, from which priority is claimed under 35 U.S.C. 120.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

By:



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PTO/SB/08A (08-00)

Approved for use through 10/31/2002. OMB 0651-0031

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| Application Number  |   | New Patent Application |   | Filing Date              |  | August 19, 2003 |  |
| First Named Inventor  |   | Taiji NODA             |   | Group Art Unit           |  | 2814            |  |
| Examiner Name   |   | H. Weiss               |   | Attorney Docket Number   |  | 740819-1027     |  |
| Sheet   | 1 | of                     | 1 |                          |  |                 |  |

  

| U.S. PATENT DOCUMENTS |                       |                      |                                      |   |   |   |  |
|-----------------------|-----------------------|----------------------|--------------------------------------|---|---|---|--|
| Examiner Initials*    | Cite No. <sup>1</sup> | U.S. Patent Document |                                      | Name of Patentee or Applicant of Cited Document | Date of Publication of Cited Document<br>MM-DD-YYYY | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |  |
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| FOREIGN PATENT DOCUMENTS |                       |                         |                     |                                      |   |   |   |                |
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| Examiner Initials*       | Cite No. <sup>1</sup> | Foreign Patent Document |                     |                                      | Name of Patentee or Applicant of Cited Document | Date of Publication of Cited Document<br>MM-DD-YYYY | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear | T <sup>6</sup> |
|                          |                       | Office <sup>3</sup>     | Number <sup>4</sup> | Kind Code <sup>5</sup><br>(if known) |   |   |   |                |
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| OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS |                       |   |                |
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| Examiner Initials*                                | Cite No. <sup>1</sup> | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T <sup>2</sup> |
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|--------------------|-----------------|
| Examiner Signature | Date Considered |
|--------------------|-----------------|

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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